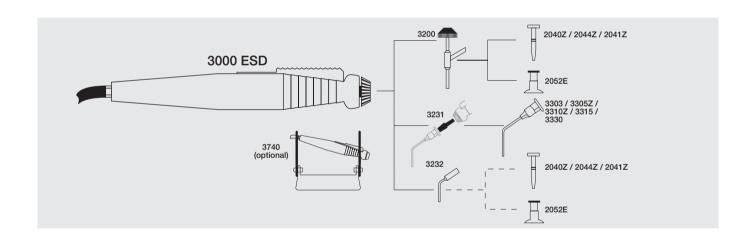
### Vacuum micromanipulator

- Professional vacuum system for precise handling of tiny SMD components and silicon wafers
- Suitable for assembly and laboratory work

### Advantages of the vacuum micromanipulator:

- Easy picking up of components or silicone wafers
- Immediate set-down/release of parts
- Full 360° rotating system
- Direct axial switch for vacuum
- Ergonomic shape reduces hand and wrist fatigue
- ESD-safe





#### Handle





140 mm/5.512 lnch 35 q

Ergonomic handle with axial switch, serrated finger grip for secure handling.

Model	Dimensions in mm/Inch	
3000ESD	Dia. 10 mm .394 Inch	Handle



## Inserts for 3000ESD housing

### **Adapters**

Model	unlu	-	Description
3200	25 mm .984 lnch	15 g	Stainless-steel adapter, rotatable through 360°, straight suction tip for direct working or as an adapter for suction tips or suction cups
3231	5 mm .197 lnch	5 g	Adapter fix, for working with Series 3300 suction tips
3232	15 mm total .590 Inch	3 g	Adapter fix, for direct working or as an adapter for suction tips 20442/20412 or suction cup 2052E

### Suction tips, straight

- Polyethylene suction tip.
- For working with 3200 or 3232 adapter.

Model		Outside diameter	Inside diameter
2044Z	Ţ	1.3 mm .051 lnch	0.9 mm .035 Inch
2041Z	T	2.0 mm .078 lnch	1.4 mm .015 Inch

## Inserts for 3000ESD housing

#### **Suction needles**

- Stainless-steel suction needle.
- Bent 45°.
- For working with 3200 or 3232 adapter.

Model	Outside diameter	Inside diameter
3303	0.30 mm .011 lnch	0.16 mm .006 Inch
3305Z	0.50 mm .020 lnch	0.25 mm .019 Inch
3310Z	1.0 mm .039 lnch	0.65 mm .025 Inch

### **Suction cups**

- Silicone suction cup.
- For working with 3200 or 3232 adapter.

Model		Diameter		
2052E	Ţ	4.5 mm .177 lnch		



## Inserts for 3000ESD housing

#### **Accessories**

Model	Description
3715Z	Diaphragm pump 230 V, 5 I/min, max. vacuum –250 mbar
3008ESD	Tube, flexible, 1.8 m/70.866 Inch, ESD-safe
3717	Filter for tube 3008ESD
3740	Table holder for 3000ESD (without accessories)

## Vacuum kit



- Complete accessories for easy pick-up and immediate set-down of components or silicon wafers.
- Set for laboratory work.
- In an ESD-safe plastic case.

Model	Description	
3000KCESD	Vacuum kit	
	contents:	
	3000ESD	Handle
	3200	Adapter, rotatable through 360°
	3231	Adapter fix
	3305Z, 3310Z, 3315	Suction needles
	2052E	Suction cup, dia. 4.5 mm / .177 Inch
	KDS 260L	Suction cup, dia. 9.5 mm / .374 Inch
	3740	Table holder
	3715z	Diaphragm pump 230 V
	3008ESD	Tube, flexible
	3717	Filter
	102ACA	SMD tweezers, 115 mm / 4.527 lnch, with bent tips and blunted edges. For vertical working with small components. Stainless steel, non-reflecting surface, non-magnetic.